

UNITED STATES PATENT AND TRADEMARK OFFICE

BEFORE THE PATENT TRIAL AND APPEAL BOARD

TAIWAN SEMICONDUCTOR MANUFACTURING COMPANY, LTD.,
TSMC NORTH AMERICA CORPORATION,
FUJITSU SEMICONDUCTOR LIMITED,
FUJITSU SEMICONDUCTOR AMERICA, INC.,
THE GILLETTE COMPANY, RENESAS ELECTRONICS
CORPORATION, RENESAS ELECTRONICS AMERICA, INC.,
ADVANCED MICRO DEVICES, INC., GLOBALFOUNDRIES U.S., INC.,
GLOBALFOUNDRIES DRESDEN MODULE ONE LLC & CO. KG,
GLOBALFOUNDRIES DRESDEN MODULE TWO LLC & CO. KG,
TOSHIBA AMERICA ELECTRONIC COMPONENTS, INC.,
TOSHIBA AMERICA INC., TOSHIBA AMERICA
INFORMATION SYSTEMS, INC., and
TOSHIBA CORPORATION,
Petitioners,
v.
ZOND, LLC,
Patent Owner

Case No. IPR2014-00861¹
Patent 6,806,652 B2

**AFFIDAVIT OF MARIA GRANOVSKY IN SUPPORT OF PATENT
OWNER'S MOTION FOR *PRO HAC VICE* ADMISSION**

¹ Cases IPR2014-00864, IPR2014-01003, and IPR2014-01066 have been joined with the instant proceeding.

I, Maria Granovsky, being duly sworn and upon oath, hereby attest to the following:

- i. I am a member in good standing of the New York and Delaware Bar, as well as the U.S. District Court for the District of Delaware.
- ii. I have not been suspended or disbarred from practice before any court or administrative body.
- iii. I have never had an application for admission to practice before any court or administrative body denied.
- iv. No sanction or contempt citation has been imposed against me by any court or administrative body.
- v. I have read and will comply with the Office Patent Trial Practice Guide and the Board's Rules of Practice for Trials set forth in part 42 of the Code of Federal Regulations.
- vi. I will be subject to the USPTO Rules of Professional Conduct set forth in 37 C.F.R. §§ 11.101 *et seq.* and disciplinary jurisdiction under 37 C.F.R. § 11.19(a).
- vii. Other than presently applying to appear *Pro Hac Vice* before the Office in connection with the *Inter Partes* Review proceedings of the patents listed below in section ix, I have not applied to appear *Pro Hac Vice* before the Office in any other proceeding in the last three years.

- viii. I am an experienced litigation attorney, with experience in many litigations involving patent infringement in District Courts across the country, including experience with fact and expert document and deposition discovery, claim construction, *Markman* hearings, motion practice, trials and hearings, and investigations before the International Trade Commission.
- ix. I am counsel for Patent Owner Zond, LLC, the plaintiff in related on-going litigations in which U.S. Patent Nos. 6,805,779, 6,806,652, 6,853,142, 6,896,773, 6,896,775, 7,147,759, 7,604,716, 7,808,184, 7,811,421, and 8,125,155 are and were asserted by the Patent Owner. I am familiar with the subject matter at issue in this proceeding as a result of my representation of Zond, LLC, in the related litigation, including the prior art that Petitioner presents in this proceeding, as well as issues of claim construction.

Date: February 24, 2015

/Maria Granovsky/
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